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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Daniel Stearns et al.

Attorney Docket: CIL-10843

Serial No. : 09/896,722

Art Unit: 1765

Filed : June 29, 2001

Examiner: R. Kunemund

For : A Method To Repair Localized Amplitude
Defects In A EUV Lithography Mask BlankNOTICE OF APPEAL FROM THE EXAMINER TO THE BOARD OF PATENT
APPEALS AND INTERFERENCESCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences
from the decision of the examiner, dated October 31, 2003, rejecting claims: 1-25 and 36.

The fee for this Notice is (37 CFR 1.17(b)) \$330.

The Commissioner is hereby authorized to charge any fees that may be
required, or credit any overpayment to Deposit Account No. 501913. I have enclosed a
duplicate copy of this sheet.

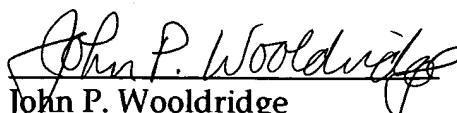
If any impediments remain, please contact the undersigned at 808-270-1011.

Respectfully submitted,

05/05/2004 HGBREH1 00000031 501913 09896722

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Dated: April 27, 2004


John P. Wooldridge
Attorney for Applicant
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